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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of: Wen-Song Tseng, et al.

Serial No.: 10/761,002

Group Art Unit: 1634

Filed: January 20, 2004

Examiner: F. Toledo

For: **WET BENCH WAFER FLOATING DETECTION SYSTEM**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING,
37 C.F.R. §1.8(a)**

I certify that this correspondence and the enclosures mentioned therein are being deposited by First Class U.S. Mail with sufficient postage on the date shown below, addressed to Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450.

Richard A. Paikoff
Richard A. Paikoff, Reg. No. 34,892

8/29/06
Date

AMENDMENT AND RESPONSE

Sir:

In response to the Office Action of May 30, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.